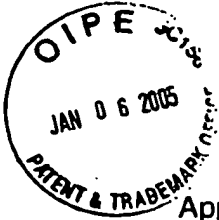


**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**



Applicant: LOEPPERT ET AL.

Serial No.: 09/910,110

Filed: JULY 20, 2001

Title: RAISED MICROSTRUCTURE OF
SILICON BASED DEVICE

Group Art Unit: 2643

Examiner: HUYEN D. LE

) I hereby certify that this paper is being
) deposited with the United States Postal
) Service as first class mail, postage
) prepaid, in an envelope addressed to:

) Mail Stop AF
) Commissioner for Patents
) P.O. Box 1450
) Alexandria, VA 22313-1450,
) on January 3, 2005.

) Randall G. Rueth
) Reg. No. 45,887

**AFTER FINAL RESPONSE TO THE ACTION
DATED NOVEMBER 3, 2004**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Final action dated November 3, 2004. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Status of the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

Do not enter
1/14/05